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**FACSIMILE COVER SHEET**

To Examiner: HO, TU TU V	Total Pages Sent: 2
Technology Center 2800	(including cover sheet)
Facsimile Number: (703) 872-9306	Transmission Date: March 1, 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

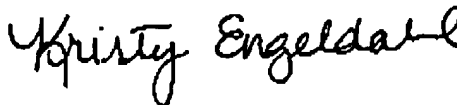
Applicant: Bao, *et al.* Docket No.: TSM03-0927  
Serial No.: 10/800,510 Art Unit: 2818  
Date Filed: March 15, 2004  
TITLE: A Semiconductor Device Having A Second Level Of Metallization Formed Over  
A First Level With Minimal Damage To The First Level And Method

**CERTIFICATION OF FACSIMILE TRANSMISSION**

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Certification of Facsimile Transmission (1 page)  
Election (1 page)

Respectfully submitted,



Kristy Engeldahl  
Legal Assistant

Confirmation Respectfully Requested

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Docket No.: TSM03-0927

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Filed: March 15, 2004

Examiner: HO, TU TU V

For: A Semiconductor Device Having A Second Level Of Metallization Formed Over A  
First Level With Minimal Damage To The First Level And Method

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on  
February 1, 2005, Applicant hereby elects Group II: Claims 24-43 for further prosecution in the  
above patent application

Respectfully submitted,

1 March 2005  
Date

James C. Kesterson  
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